

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jiang et al.

Art Unit: 1765

Serial No.: 09/966,605

Examiner: Vinh, Lan

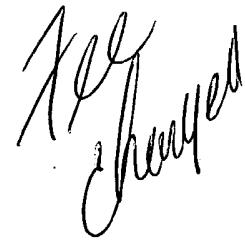
Filing Date: 09/28/2001

Docket No.: TI-31462

Customer No.: 23494

Conf. No.: 4769

Title: IN-SITU PLASMA ASH/TREATMENT AFTER VIA ETCH OF LOW-K FILMS FOR POISON-FREE DUAL DAMASCENE TRENCH PATTERNING

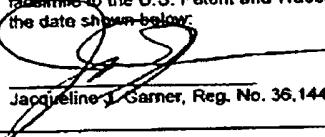
REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
 PO Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:


Jacqueline J. Garner, Reg. No. 36,144April 19, 2004
Date

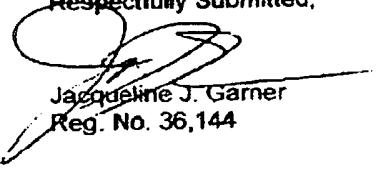
Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

One Month (\$110)
 Two Months (\$420)
 Three Months (\$950)
 Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

Respectfully Submitted,


Jacqueline J. Garner

Reg. No. 36,144

Texas Instruments Incorporated
 PO Box 655474, M/S 3999
 Dallas, TX 75265
 (214) 532-9348
 Fax: (972) 917-4418

04/22/2004 RHOLLAND 00000002 200668 09966605

01 FC:1252 420.00 DA